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Name: C. Fong

By: C. Forg

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mary CHAN-PARK, et al.

Application Serial No: 09/784,972

Description of the Application of the Appl

For: PROCESS FOR ROLL-TO-ROLL
MANUFACTURE OF A DISPLAY BY
SYNCHRONIZED

PHOTOLITHOGRAPHIC EXPOSURE ON A SUBSTRATE WEB

Attorney's Docket No. 26822-0006

PROPINED TOO

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, D.C. 20231

Filed: February 15, 2001

Dear Sir:

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Please preliminarily amend the above application as indicated below.

IN THE CLAIMS

Please add new claims 46-52.

- 46. A photolithographic process comprising imagewise exposure through a moving photomask synchronized with a moving web substrate.
- 47. The process of Claim 46 wherein said web substrate comprises a conductor layer on a plastic substrate in which said conductor layer is coated with a radiation sensitive material.
- 48. The process of Claim/47 wherein said conductor layer is ITO on PET (polyethyelne terephthalate), PEN (polyethylene naphthate) or polycarbonate.
- 49. The process of Claim 47 wherein said radiation sensitve material is a positive photoresist.